

17348
2/19/03

PATENT
Docket No.: Q106-US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hisashi Tsukamoto et al.

Application No.: 10/031,022

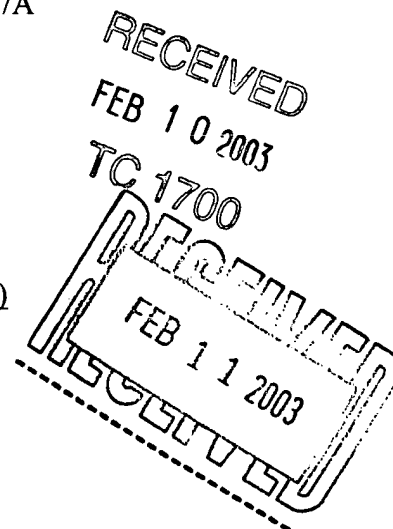
Group Art Unit: 1734

Filing Date: January 14, 2002

Examiner: N/A

Title: LITHIUM THIN FILM
LAMINATION TECHNOLOGY
ON ELECTRODE TO INCREASE
BATTERY CAPACITY

CERTIFICATE OF MAILING VIA
CERTIFIED FIRST CLASS MAIL (37 CFR 1.8)
Dated January 29, 2003



Commissioner for Patents
Washington, D.C. 20231

I hereby certify that the following attached documents are being deposited with the United States Postal Service as first class certified mail under 37 CFR 1.8 on the date indicated above and are addressed to Commissioner for Patents, Washington, D.C. 20231.

1. Transmittal Letter for Information Disclosure Statement (in duplicate)
2. PTO Form 1449 with copy of cited reference
3. Self addressed stamped return postcard

January 29, 2003

Date of Deposit

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Name of Person Mailing paper or fee

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